

UNITED STATES DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

PATENT

In the application:

Inventors: HE, Ting et al.
Serial Number: 10/757,302
Filed: January 14, 2004

For: HIGH THROUGHPUT PHYSICAL VAPOR DEPOSITION SYSTEM
FOR MATERIAL COMBINATORIAL STUDIES

Group Art Unit: 1763
Examiner: Richard R. Bueker

Atty. Docket No.: 3994994-148069 CONFIRMATION NO. 4457

**Response to Notice of Non-Compliant Amendment Mailed 10/12/010 for
Amendment and Response to Office Action Mailed on June 25, 2010**

By E-file [registered user] on OCTOBER 20, 2010
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

To the Honorable Commissioner:

In response to the Notice of Non-Compliant Amendment Mailed 10/12/010, please find the corrected claim set and response to Office Action Mailed on June 25, 2010. Entry of this corrected amendment, reexamination and reconsideration is requested.

- 1) Corrected Amendments to the Claims begin on page 2; and
- 3) Remarks begin on page 6.

///